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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: **METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND
AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING**

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The undersigned respectfully requests to be advised of the status of the above-identified application.

Respectfully submitted,

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: August 19, 2005

Attorney Docket No.: Q63075